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| | Application No. | Applicant(s) |
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| Notice of Allowability | 10/730,094 | MIURA, NORIYUKI |
| | Examiner | Art Unit |
| | Remmon R. Fordé | 2826 |
| The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT Re of the Office or upon petition by the applicant. See 37 CFR 1.313 | ars on the cover sheet with the (OR REMAINS) CLOSED in this a or other appropriate communication GHTS. This application is subject | correspondence address pplication. If not included on will be mailed in due course. THIS |
| 1. This communication is responsive to <u>12/09/2003</u> . | | <i>;</i> |
| 2. X The allowed claim(s) is/are 1-5. | | |
| 3. \boxtimes The drawings filed on <u>09 December 2003</u> are accepted by | the Examiner. | |
| 4. Acknowledgment is made of a claim for foreign priority un a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have 1. Cepies of the certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have 1. Certified copies not received: POT Rule 17.2(a)). * Certified copies of the priority documents have and tree in the priority documents have and | been received. been received in Application Note Parametris have been received in this cuments have been received in this post this communication to file a replication. Itted. Note the attached EXAMINED is reason(s) why the oath or declar to be submitted. It be submitted. It is application in the submitted. It is application in the submitted in the submitted. It is application in the submitted in the subm | y complying with the requirements R'S AMENDMENT or NOTICE OF ration is deficient. 0-948) attached Office action of rings in the front (not the back) of 1(d). must be submitted. Note the |
| Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0: Paper No./Mail Date 12/09/2003 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material | 6. ☐ Interview Summar Paper No./Mail Da 8), 7. ⊠ Examiner's Amend | |

EXAMINER'S AMENDMENT

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Adam C. Volentine on 12/10/2004.

The application has been amended as follows:

<u>Claims</u>

In claim 4, line 16, remove "; and" replace with ---.--

Reasons For Allowance

The following is an examiner's statement of reasons for allowance:

Claims 1-5 are allowed.

Claim 1 recites a semiconductor device structure including the specific structural limitations of providing a buried insulating film formed in that region of the SOI layer which lies between the source region and the drain region and under the gate insulating film; and a non-doped silicon film formed between the buried insulating film and the gate insulating film in contact with a top surface of the buried insulating film and serving as a channel region. The abovementioned structural limitations are neither anticipated by

nor obvious over the prior art of record. Likewise, claims 2-5 are also allowable as being dependent upon allowable claim 1.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Relevant Prior Art

The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Ikeda, Adan and Ono each recite SOI semiconductor devices.

Contact Information

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Remmon R. Fordé whose telephone number is (571) 272-1916. The examiner can normally be reached on Monday-Thursday (8:00-6:30).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nathan J. Flynn can be reached on (571) 272-1915. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Remmon R. Fordé